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# Widely tunable Y-junction lasers at 2.34 – 2.39 µm wavelength for trace-gas sensing applications

Thanh-Nam Tran, Saroj Kumar Patra, Kjetil Haddeland, Magnus Breivik, and Bjørn-Ove Fimland

Abstract— Widely tunable Y-junction lasers have been realized in the wavelength range of 2.34 - 2.39  $\mu$ m for trace-gas sensing application. Y-junction structures with large bend radius and small length difference between the two cavities have been chosen to maximize the output power and wavelength tunability while having sufficient side mode suppression ratio (SMSR). By changing the electric currents in different sections of the Yjunction lasers, a tunable wavelength range of 50 nm with an SMSR > 23 dB was achieved.

Index Terms—Tunable diode lasers, Y-junction, mid-infrared, Gallium Antimonide (GaSb), side mode suppression ratio (SMSR).

### I. INTRODUCTION

GaSB-BASED type-I semiconductor diode lasers with high optical gain, simple growth design and easy approach to continuous wave (cw) operation at room temperature (RT) are excellent candidates for mid-infrared lasers in the wavelength region of 1.5-3.3  $\mu$ m [1-3], whose applications include the monochromatic light sources needed for trace-gas sensing systems based on tunable diode-laser absorption spectroscopy (TDLAS). The drawback of GaSb-based type-I lasers compared to the well-known quantum cascade lasers in trace-gas sensing applications [4-7] is that as the emission wavelength increases, the internal loss of this type of lasers rises due to stronger free-carrier absorption and restricts their operation at long

wavelengths beyond 3.3 µm. Among edge-emitting laser structures for light source of TDLAS, Y-junction structure is an interesting alternative, thanks to its wide tunable range and less complex fabrication process. Most of widely tunable monolithic laser structures benefit from passive gratings and phase sections, requiring epitaxial regrowth of the laser structure [8]. This regrowth could be performed for GaSb-based laser structures [9], but has to overcome the reactive nature of AlGaAsSb [10] used for the cladding layers. Y-junction lasers provide a regrowth-free solution, using less complex processing steps and tools (such as conventional photolithography), resulting in potentially lower costs and higher yield. First studied by Wang, Choi and Fattah [11, 12], the Y-junction lasers were later further developed by other groups focusing on optical communication applications [13-17]. Recently, tunable lasers using Y-junction [18, 19] or related structures such as Mach-Zehnder (MZ) interferometer [20-23], V-coupled cavity [24], modulated grating Y-branch [25] and multimode interference couplers [26, 27] have been investigated, typically for gas sensing and communication applications. For the regrowth-free, low-cost tunable lasers, a tuning range of up to 55 nm and an SMSR exceeding 30 dB have been reported for the wavelength region of 1.5-1.6 µm [22, 26-28].

In the present work, the ridge waveguide Y-junction structure, which can be considered a "half MZ interferometer", consists of two S-bend cavities with same bending radius sharing a common section, as shown in Fig. 1, but where one Sbend cavity is shorter due to a shorter bend section. The geometrical path difference  $\Delta L$  allows the selection of the overlapped modes (supermodes) between two mode-combs of these two cavities, called the Vernier effect, thus enabling the interferometric tuning behavior of the Y-junction lasers when the mode-comb of one cavity is shifted relative to the other. Here, Y-junction lasers of different configuration (i.e., different bend radii r and  $\Delta L$ ) have been fabricated and characterized. The main goal is to maximize wavelength tuning range while keeping the SMSR sufficient for gas detection [29]. With the tuning range of 2.34 – 2.39 µm, several targeted gas molecules

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can be detected such as  $CH_4$  and CO, which have strong absorption lines in this wavelength regime [30-32].

#### II. EXPERIMENTAL

In this study, GaInAsSb/AlGaAsSb quantum well (QW) diode lasers emitting at 2.3 µm wavelength were grown on ntype GaSb (001) wafer by molecular beam epitaxy (MBE). The active region consisted of three 12 nm wide Ga<sub>0.67</sub>In<sub>0.33</sub>As<sub>0.10</sub>Sb<sub>0.90</sub> QWs separated by 20 nm wide quaternary  $Al_{0.35}Ga_{0.65}As_{0.026}Sb_{0.974}$ barrier layers and sandwiched between two 145 nm wide undoped Al<sub>0.35</sub>Ga<sub>0.65</sub>As<sub>0.026</sub>Sb<sub>0.974</sub> separate confinement layers. For optical and electrical confinement, the active region was surrounded by n- and p-type doped Al<sub>0.90</sub>Ga<sub>0.10</sub>As<sub>0.06</sub>Sb<sub>0.94</sub> cladding layers with the thickness of 2 and 1.4 µm, respectively. The carrier concentration in the cladding layers has been optimized to enhance the laser performance [33].

5 µm wide ridge Y-junction lasers, with locally symmetric Y-splitter structure and with different bend radii r and length differences  $\Delta L$ , were processed into the structure shown schematically in Fig. 1. For the loss characterization in the Yjunction structure, straight lasers with the same waveguide width were also fabricated for comparison. To improve the light confinement in the Y-junction structure, especially in the bend sections, a deep etch (within 100 nm above the active region) is important. The etch depth can be precisely controlled by in situ reflectance monitoring [34]. For the contact planarization and waveguide sidewall isolation, photoresist ma-N440 was spincoated followed by thermal hardening and O2/CF4 Reactive Ion Etching etchback. Prior to metallization, in situ cleaning of the GaSb surface by optimal-ion-energy (180 eV) Ar<sup>+</sup> irradiation was applied to remove the native oxide [35]. The conventional gold-based contacts, Ti/Pt/Au and Pd/Ge/Au/Pt/Au, were used for top and bottom laser contacts, respectively, followed by annealing. The lasers were cleaved into bars of 1.5 mm before being mounted epi-side-up on copper heat sinks. The laser diodes were characterized in cw operation at 16 °C without any facet coatings.



Fig. 1. Schematic of a fabricated Y-junction laser with three top electrodes for current injection, where  $I_c$ ,  $I_s$  and  $I_l$  are the injected currents for the common section, the shorter arm and the longer arm, respectively.

#### III. RESULTS AND DISCUSSIONS

Fig. 2 shows the output power characteristics of Y-junction lasers with different bend radii where all three currents were kept identical. The typical Y-junction laser ( $r = 1000 \ \mu m$ ,  $\Delta L =$ 20  $\mu$ m) exhibits a relatively high threshold current density  $J_{\rm th}$  of 1140 A/cm<sup>2</sup> (380 A/cm<sup>2</sup> per well) compared to the straight waveguide lasers ( $J_{\text{th}} = 750 \text{ A/cm}^2$ ). A significant contribution to the high threshold current density is the bend losses not found in the straight laser structures. The inset in Fig. 2 displays the single-mode behavior of the Y-junction lasers emitting at 2.37 µm with an SMSR of 25 dB. The laser linewidth or the full width at half maximum (FWHM) of laser peak is measured to be ~0.1 nm which is suitable for high accuracy gas sensing applications as simulated by Chan et al. [36]. The characteristic temperature  $(T_0)$  of 84.3 K measured from straight waveguide lasers of the same laser growth structure indicates a good thermal stability of the devices.



Fig. 2. Output performance of the Y-junction lasers with different bend radii. Single-mode emission with SMSR = 25 dB is shown in the upper inset, recorded for the Y-junction configuration with  $r = 1000 \ \mu\text{m}$  and  $\Delta L = 20 \ \mu\text{m}$ . (See Fig. 1 for definition of  $I_c$ ,  $I_l$  and  $I_{s-}$ )

The design of the bend section in the Y-junction structure significantly affects the performance of the final devices in terms of output power and wavelength tunability. As the bend radius decreases, the optical losses due to leakage in the bend section and the mode mismatch between the straight and bent waveguide segments increases, resulting in higher total loss and lower output power [37, 38], as seen in Fig. 2. Moreover, for a given waveguide separation, the bend radius also determines the length difference  $\Delta L$  between two cavities in the asymmetric Y-junction structure. The larger the bend radius, the smaller  $\Delta L$  can be, and thus a higher tuning range, given by  $\Delta \lambda_Y = \lambda^2 / 2n_{\text{g,eff}} \Delta L$  where  $n_{\text{g,eff}}$  is the effective group index, can be achieved. Therefore, larger bend radius is preferable to maximize the output power and the tuning range. With  $n_{g,eff} = 3.75$  (determined from mode spacing measurements), the theoretical tuning range of the Y-junction lasers with the largest  $r = 1000 \,\mu\text{m}$  and  $\Delta L = 20 \,\mu\text{m}$  in this study is  $\Delta\lambda_Y = 36.5$  nm, which is in agreement with the experimental results presented in Fig. 3(a) (i.e., by keeping  $I_c = I_s = 120$  mA and varying  $I_l$ , the tuning range is 37 nm with an average tuning rate of 0.6 nm/mA). The drawback of the Y-junction configuration is the tradeoff between increased tuning range and the associated reduction in SMSR [15]. However, a typical SMSR of 23 dB and up to 25 dB is obtained in this work, which satisfies the requirement for trace-gas sensing application.



Fig. 3. Tuning behavior of Y-junction laser with  $r = 1000 \mu m$  and  $\Delta L = 20 \mu m$ . (a) Variation of the MZ filter across the FP modes. (b) Variation of the whole gain curve across the MZ filter.

The tuning behavior of the Y-junction lasers has been characterized as shown in Fig. 3. By adjusting the injection currents into each section, the emitted wavelength can be tuned in two different ways which allow the largest variety of controllable applications [15]. The first tuning scheme is based on the variation of the MZ filter across the Fabry-Perot (FP) modes. By varying the ratio of the injection currents into the longer arm ( $I_l$ ) and the shorter arm ( $I_s$ ), the sawtooth-shaped tuning behavior can be observed as shown in Fig. 3(a) when the position of the MZ loss minimum is tuned across the allowed FP modes (continuous tuning) until the neighboring minimum reaches the same low level (step-like tuning). The single-mode lasing spectra with a tuning range of 32 nm covered in steps of 1-3 nm is displayed in Fig. 4. By combining with variations of the injected current into the common section ( $I_c$ ), a wide tuning range of up to 50 nm can be obtained. This would be advantageous as it can enable several gases to be detected by one single laser. The second tuning scheme is achieved by changing all of the injected currents simultaneously (usually equal) to shift the whole gain curve across the MZ filter. Step-like tuning behavior can be observed, as shown in Fig. 3(b), resulting from the switch of the supermode when the level of the next MZ loss minimum has reached the value of the previous one.



Fig. 4. Single-mode lasing spectra (with normalized peak intensities) of the Y-junction laser ( $r = 1000 \text{ } \mu\text{m}$ ,  $\Delta L = 20 \text{ } \mu\text{m}$ ) with a 32 nm tuning range.

## IV. CONCLUSIONS

Tunable Y-junction lasers lasing at  $2.34 - 2.39 \mu m$  wavelength have been successfully fabricated and characterized. A single-mode emission tuning range as wide as 50 nm is demonstrated for Y-junction laser with bend radius of 1000  $\mu m$  and length difference of 20  $\mu m$  between the two cavities. In addition, the devices exhibit good output performance in terms of power, FWHM and SMSR that makes Y-junction laser a promising candidate for trace-gas sensing applications.

#### REFERENCES

- G. Almuneau, F. Genty, A. Wilk, P. Grech, A. Joullié, and L. Chusseau, "GaInSb/AlGaAsSb strained quantum well semiconductor lasers for 1.55 µm operation," *Semicond. Sci. Technol.*, vol. 14, no. 1, pp. 89, Jan. 1999, doi: 10.1088/0268-1242/14/1/014.
- [2] T. Hosoda, G. Kipshidze, L. Shterengas, and G. Belenky, "Diode lasers emitting near 3.44 μm in continuous-wave regime at 300K," *Electron. Lett.*, vol. 46, no. 21, pp. 1455-1457, Oct. 2010, doi: 10.1049/el.2010.2564
- [3] E. Tournié, and A. N. Baranov, "Mid-infrared semiconductor lasers," in Advances in Semiconductor Lasers (Semiconductor and Semimetals series), vol. 86, J. J. Coleman, A. C. Bryce, and C. Jagadish, Eds. New York, NY, USA: Academic, 2012, p. 183.
- [4] J. Li, U. Parchatka, and H. Fischer, "Development of field-deployable QCL sensor for simultaneous detection of ambient N<sub>2</sub>O and CO," *Sens. Actuators B Chem.*, vol. 182, pp. 659-667, Jun. 2013, doi: 10.1016/j.snb.2013.03.073.

#### PTL-39988-2023

- [5] W. Ren, W. Jiang, and F. K. Tittel, "Single-QCL-based absorption sensor for simultaneous trace-gas detection of CH<sub>4</sub> and N<sub>2</sub>O," *Appl. Phys. B*, vol. 117, pp. 245-251, Apr. 2014, doi: 10.1007/s00340-014-5828-8.
- [6] J. Li, H. Deng, J. Sun, B. Yu, and H. Fischer, "Simultaneous atmospheric CO, N<sub>2</sub>O and H<sub>2</sub>O detection using a single quantum cascade laser sensor based on dual-spectroscopy techniques," *Sens. Actuators B Chem.*, vol. 231, pp. 723-732, Aug. 2016, doi: 10.1016/j.snb.2016.03.089.
- [7] P. M. Hundt, B. Tuzson, O. Aseev, C. Liu, P. Scheidegger, H. Looser, F. Kapsalidis, M. Shahmohammadi, J. Faist, and L. Emmenegger, "Multi-species trace gas sensing with dual-wavelength QCLs," *Appl. Phys. B*, vol. 124, no. 6, p. 108, May 2018, doi: 10.1007/s00340-018-6977-y.
- [8] J. Buus, M. C. Amann, and D. J. Blumenthal, *Tunable diode lasers and related optical sources*, Hoboken, NJ, USA: John Wiley & Sons, Inc., 2005, pp. 169-220.
- [9] Q. Gaimard, M. Triki, T. N. -Ba, L. Cerutti, G. Boissier, R. Teissier, A. Baranov, Y. Rouillard, and A. Vicet, "Distributed feedback GaSb based laser diodes with buried grating: a new field of single-frequency sources from 2 to 3 μm for gas sensing applications," *Opt. Express*, vol. 13, no. 15, pp. 19118-19128, Jul. 2015, doi: 10.1364/OE.23.019118.
- [10] M. Reason, B. Bennett, R. Magno, and J. B. Boos, "Molecular Beam Epitaxial Regrowth of Antimonide-Based Semiconductors," *J. Electron. Mater.*, vol. 40, no. 1, pp. 6-10, Jan. 2011, doi: 10.1007/s11664-010-1399-6.
- [11] S. Wang, H. K. Choi, and I. H. A. Fattah, "Studies of semiconductor lasers of the interferometric and ring types," *IEEE J. Quantum Electron.*, vol. 18, no. 4, pp. 610-617, Apr. 1982, doi: 10.1109/JQE.1982.1071587.
- [12] I. H. A. Fattah, and S. Wang, "Semiconductor interferometric laser," *Appl. Phys. Lett.*, vol. 41, no. 2, pp. 112-114, Jul. 1982, doi: 10.1063/1.93444.
- [13] M. Schilling, H. Schweizer, K. Dütting, W. Idler, E. Kühn, A. Nowitzki, and K. Wünstel, "Widely tunable Y-coupled cavity integrated interferometric injection laser," *Electron. Lett.*, vol. 26, no. 4, pp. 243-244, Feb. 1990, doi: 10.1049/el:19900163.
- [14] M. Schilling, W. Idler, E. Kühn, G. Laube, H. Schweizer, K. Wünstel, and O. Hildebrand, "Integrated interferometric injection laser: novel fast and broad-band tunable monolithic light source," *IEEE J. Quantum Electron.*, vol. 2727, no. 6, pp. 1616-1624, Jun. 1991, doi: 10.1109/3.89985.
- [15] K. Dütting, O. Hildebrand, D. Baums, W. Idler, M. Schilling, and K. Wünstel, "Analysis and simple tuning scheme of asymmetric Y-lasers," *IEEE J. Quantum Electron.*, vol. 30, no. 3, pp. 654-659, Mar. 1994, doi: 10.1109/3.286151.
- [16] O. Hildebrand, W. Idler, K. Dütting, G. Laube, and K. Wünstel, "The Ylaser: a multifunctional device for optical communication systems and switching networks," *J. Lightwave Technol.*, vol. 11, no. 12, pp. 2066-2075, Dec. 1993, doi: 10.1109/50.257971.
- [17] M. Kuznetsov, P. Verlangieri, A. G. Dentai, C. H. Joyner, and C. A. Burrus, "Asymmetric Y-branch tunable semiconductor laser with 1.0 THz tuning range," *IEEE Photon. Technol. Lett.*, vol. 4, no. 10, pp. 1093-1095, Oct. 1992, doi: 10.1109/68.163743.
- [18] R. Bugge, and B. -O. Fimland, "A novel tunable wet etched mid-IR pentenary AlInGaAsSb junction laser at 2.34-2.44 µm," in *Proc. DRC'05*, Santa Barbara, CA, USA, 2005, doi: 10.1109/DRC.2005.1553035.
- [19] A. Lyakh, R. Maulini, A. Tsekoun, R. Go, and C. K. N. Patel, "Continuous wave operation of buried heterostructure 4.6µm quantum cascade laser Yjunctions and tree arrays," *Opt. Express*, vol. 22, no. 1, pp. 1203-1208, Jan. 2014, doi: 10.1364/OE.22.001203.
- [20] M. C. Zheng, P. Q. Liu, X. Wang, J. -Y. Fan, M. Troccoli, and C. F. Gmachl, "Wide single-mode tuning in quantum cascade lasers with asymmetric Mach-Zehnder interferometer type cavities with separately biased arms," *Appl. Phys. Lett.*, vol. 103, no. 21, pp. 211112, Nov. 2013, doi: 10.1063/1.4832337.
- [21] P. Q. Liu, X. Wang, and C. F. Gmachl, "Single-mode quantum cascade lasers employing asymmetric Mach-Zehnder interferometer type cavities," *Appl. Phys. Lett.*, vol. 101, no. 16, pp. 161115, Oct. 2012, doi: 10.1063/1.4761247.
- [22] M. Dernaika, L. Caro, N. P. Kelly, M. Shayesteh, and F. H. Peters, "Tunable L-band semiconductor laser based on Mach–Zehnder interferometer," *Opt. Commun.*, vol. 402, pp. 56-59, Nov. 2017, doi: 10.1016/j.optcom.2017.05.073.
- [23] S. Latkowski, A. Hänsel, P. J. van Veldhoven, D. D'Agostino, H. Rabbani-Haghighi, B. Docter, N. Bhattacharya, P. J. A. Thijs, H. P. M. M. Ambrosius, M. K. Smit, K. A. Williams, and E. A. J. M. Bente, "Monolithically integrated widely tunable laser source operating at 2 μm," *Optica*, vol. 3, no. 12, pp. 1412-1417, Dec. 2016, doi: 10.1364/OPTICA.3.001412.

- [24] J. Jin, L. Wang, T. Yu, Y. Wang, and J. -J. He, "Widely wavelength switchable V-coupled-cavity semiconductor laser with ~40 dB side-mode suppression ratio," *Opt. Lett.*, vol. 36, no. 21, pp. 4230-4232, Nov. 2011, doi: 10.1364/OL.36.004230.
- [25] J. –O. Wesstrom, G. Sarlet, S. Hammerfeldt, L. Lundqvist, P. Szabo, and P. –J. Rigole, "State-of-the-art performance of widely tunable modulated grating Y-branch lasers," in *Proc. OFC 2004*, Los Angeles, CA, USA, 2004. [Online]. Available: https://ieeexplore.ieee.org/document/1359295.
- [26] D. D'Agostino, D. Lenstra, H. Ambrosius, and M. Smit, "Widely tunable multimode-interference based coupled cavity laser with integrated interferometer," *Opt. Express*, vol. 26, no. 11, pp. 14159-14173, May 2018, doi: 10.1364/OE.26.014159.
- [27] L. Caro, M. Dernaika, N. P. Kelly, P. E. Morrissey, J. K. Alexander, and F. H. Peters, "An Integration-Friendly Regrowth-Free Tunable Laser," *IEEE Photon. Technol. Lett.*, vol. 30, no. 3, pp. 270-272, Feb. 2017, doi: 10.1109/LPT.2017.2781799.
- [28] M. Nawrocka, Q. Lu, W. -H. Guo, A. Abdullaev, F. Bello, J. O'Callaghan, T. Cathcart, and J. F. Donegan, "Widely tunable six-section semiconductor laser based on etched slots," *Opt. Express*, vol. 22, no. 16, pp. 18949-18957, Aug. 2014, doi: 10.1364/OE.22.018949.
- [29] Y. Rouillard, S. Belahsene, M. Jahjah, G. Boissier, P. Grech, G. Narcy, A. Vicet, L. Naehle, M. v. Edlinger, M. Fischer, and J. Koeth, "Quantum well lasers emitting between 3.0 and 3.4 μm for gas spectroscopy," in *Proc. SPIE OPTO*, vol. 8268, San Francisco, CA, USA, 2012, doi: 10.1117/12.905881.
- [30] I. E. Gordon, L. S. Rothman, R. J. Hargreaves, R. Hashemi, E. V. Karlovets, F. M. Skinner, E. K. Conway, C. Hill, R. V. Kochanov, Y. Tan, P. Wcisło, A. A. Finenko et al., "The HITRAN2020 molecular spectroscopic database," *J. Quant. Spectrosc. Radiat. Transf.*, vol. 277, p. 107949, Jan. 2022, doi: 10.1016/j.jqsrt.2021.107949.
- [31] M. Jahjah, S. Moumdji, O. G. -Lafaye, S. Bonnefont, Y. Rouillard, and A. Vicet, "Antimonide-based 2.3 μm photonic crystal coupled-cavity lasers for CH<sub>4</sub> QEPAS," *Electron. Lett.*, vol. 48, no. 5, pp. 277-278, Mar. 2012, doi: 10.1049/el.2011.3614.
- [32] E. V. Stepanov, S. N. Kotelnikov, A. Y. Stavtsev, and S. G. Kasoev, "The best absorption lines for the detection of carbon monoxide at 2.35 micron with tunable diode lasers," *J. Phys.: Conf. Ser.*, vol. 1560, p. 012053, 2020, doi: 10.1088/1742-6596/1560/1/012053.
- [33] S. K. Patra, T. -N. Tran, L. Vines, I. Kolevatov, E. Monakhov, and B. -O. Fimland, "Dopant incorporation in Al<sub>0.9</sub>Ga<sub>0.1</sub>As<sub>0.06</sub>Sb<sub>0.94</sub> grown by molecular beam epitaxy," *J. Cryst. Growth*, vol. 463, pp. 116-122, Apr. 2017, doi: 10.1016/j.jcrysgro.2017.01.035.
- [34] T. -N. Tran, M. Breivik, S. K. Patra, and B. -O. Fimland, "High precision AlGaAsSb ridge-waveguide etching by in situ reflectance monitored ICP-RIE," in *Proc. SPIE Photonics Europe*, vol. 9134, Brussels, Belgium, 2014, doi: 10.1117/12.2052615.
- [35] T. -N. Tran, S. K. Patra, M. Breivik, and B. -O. Fimland, "Plasma-assisted oxide removal from p-type GaSb for low resistivity ohmic contacts," *J. Vac. Sci. Technol. B*, vol. 33, no. 6, pp. 061210, Oct. 2015, doi: 10.1116/1.4935883.
- [36] K. L. Chan, Z. Ning, D. Westerdahl, K. C. Wong, Y. W. Sun, A. Hartl, and M. O. Wenig, "Dispersive infrared spectroscopy measurements of atmospheric CO<sub>2</sub> using a Fabry–Pérot interferometer sensor," *Sci. Total Environ.*, vol. 472, pp. 27-35, Feb. 2014, doi: 10.1016/j.scitotenv.2013.10.105.
- [37] J. Wang, W. Yuan, C. S. Seibert, and D. C. Hall, "Loss characterization of high-index-contrast ridge waveguide oxide-confined InAlGaAs quantum well racetrack ring-resonator lasers," in *Proc. SPIE OPTO*, vol. 7230, San Jose, CA, USA, 2009, doi: 10.1117/12.807871.
- [38] M. Breivik, "Fabrication of mid-infrared laser diodes for gas sensing applications," Ph.D. dissertation, Dept. Electron. Syst., Norwegian Univ. Sci. Technol., Trondheim, Norway, 2013.